



ant: Aratani, et al.

Serial No.: 09/429,719

Filed: October 29, 1999

For: THIN FILM FORMATION, USE SPUTTERING TARGET MATERIAL, THIN FILM FORMED USING SAME, AND OPTICAL RECORDING MEDIUM

Case No.: 9792486-0100

Group Art Unit: 1753

Examiner: R. McDonald

Date: January 25, 2002

Certificate of Mailing (37 CFR 1.8(a))

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to:

Assistant Commissioner for Patents Washington, D.C. 20231, on:

Date of Deposit: January 25, 2002

Date

RECEIVED TO 1700

TRANSMITTAL LETTER

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Enclosed herewith is a Response "D" to First Non-Final Office Action After RCE Filing of Aratani, et al. in the above-identified patent application.

Also enclosed are: Affidavit Under 37 CFR 1.131 and Exhibits A and B
Return Receipt Postcard

The Commissioner is hereby authorized to charge any additional fees required, as well as any patent application processing fees associated with this communication for which full payment has not been tendered, to Deposit Account No. 19-3140. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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